

**RESPONSE AFTER FINAL
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Art Unit: 1795

Application No.: 10/658,460

Examiner: Rodney Glenn McDONALD

Filed: September 10, 2003

Attorney Docket No.: 029567-00004

For: **BIAS SPUTTERING FILM FORMING PROCESS AND BIAS
SPUTTERING FILM FORMING APPARATUS**

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TO
ENTER
RCO
6-4-08

~~DO NOT ENTER: /RM/~~

AMENDMENT UNDER 37 C.F.R. § 1.116

~~04/23/2008~~

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

April 16, 2008

Sir:

In reply to the February 4, 2008, Office Action, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, begin on page 2;

and

Remarks begin on page 4.